



IPW

Reference to:
Application No.: 10/723,046
Filing date: 11/26/2003
Art unit: 2811
Applicants: Hui Peng
Title: Texture on Substrate and a Method for Minimizing Effects of Lattice Mismatch
Examiner/Art Unit Shouxiang Hu/2811

Fremont, CA, Feb. 17 , 2005

AMENDMENT A

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This letter responses to the Office Action Summary dated Nov. 26, 2004 and mailed to applicant on 12/01/2004. Please amend the above patent application as the following.

TITLE: Amendment to the title of the above patent application is on page 2 of this amendment.

SPECIFICATION: There is no amendment to the specification.

CLAIMS: Amendment to the claims of the above patent application begin on page 3 of this amendment.

DRAWINGS: There is no amendment to the drawings.

REMARKS: Remarks begin on page 5 of this amendment.



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